

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)	Confirmation No.: 1187
Koichiro TANAKA et al.)	Examiner: Sang Y. Paik
Serial No.: 10/579,238)	Group Art Unit: 3742
Filed: May 12, 2006)	
For: LASER IRRADIATION APPARATUS)	
AND LASER IRRADIATION METHOD)	

AMENDMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated February 17, 2010, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 8 of this paper.